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	Application No.	Applicant(s)	+
	10/748,952	IKEDA ET AL.	
Notice of Allowability	Examiner	Art Unit	_
	PHAN T.H. PALMER	2874	
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGOT THE OFFICE OF THE OFFICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGOT THE OFFICE OF THE OFFICE O	OR REMAINS) CLOSED in this or other appropriate communica GHTS. This application is subje	application. If not included attion will be mailed in due course. THIS	ve
1. This communication is responsive to 12/30/2003.			
2. 🔀 The allowed claim(s) is/are <u>1-20</u> .			
3. ☐ Acknowledgment is made of a claim for foreign priority und a) ☐ All b) ☐ Some* c) ☐ None of the:		. · ·	
1. Certified copies of the priority documents have	been received.		
2. Certified copies of the priority documents have	• • •		
Copies of the certified copies of the priority doc	uments have been received in t	his national stage application from the	
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONMETHIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		ply complying with the requirements	
4. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give:	tted. Note the attached EXAMIN s reason(s) why the oath or decl	ER'S AMENDMENT or NOTICE OF laration is deficient.	
5. CORRECTED DRAWINGS (as "replacement sheets") must	t be submitted.		
(a) ☐ including changes required by the Notice of Draftsperso		TO-948) attached	
1) ☐ hereto or 2) ☐ to Paper No./Mail Date	- ·	·	
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	Amendment / Comment or in th	e Office action of	
Identifying indicia such as the application number (see 37 CFR 1.8 each sheet. Replacement sheet(s) should be labeled as such in the			
 DEPOSIT OF and/or INFORMATION about the depos attached Examiner's comment regarding REQUIREMENT F 	it of BIOLOGICAL MATERIA FOR THE DEPOSIT OF BIOLOG	L must be submitted. Note the GICAL MATERIAL.	
Attachment(s)			
1. ☑ Notice of References Cited (PTO-892)	5. Notice of Information	al Patent Application (PTO-152)	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Summ Paper No./Mail		
 Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date 12/30/2005 	B), 7. ⊠ Examiner's Ame	ndment/Comment	
Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. X Examiner's State	ement of Reasons for Allowance	
G	9.	Brant. H. Palmer PHAN T. H. PALMER PRIMARY EXAMINER	
		10/31/2005	

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EXAMINER'S AMENDMENT Amdt/PAHP

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows: in the specification, on page 1, line 3, after "No." inserted --10/749,029--; and on line 5, after "Serial No." inserted --10/748,950--.

REASON FOR ALLOWANCE

2. The following is an examiner's statement of reasons for allowance: the claims are allowable over prior art of record, because none references in alone or in combination discloses:

+++ An adjustable aperture system, comprising:

- a stationary aperture operable to remove a portion of a lower intensity light communicated through a light bundle;
- an adjustable aperture comprising <u>a notch and capable of varying an</u>

 <u>amount of projection light communicated through the light bundle</u>, <u>wherein the</u>

 <u>notch operates to reduce the effect of the adjustable aperture on a high intensity</u>

 <u>light communicated through the light bundle</u>; and
- a control motor operable to receive a control signal and to selectively manipulate the adjustable aperture, as discloses in claim 1.

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+++ An image display system, comprising:

- a modulator operable to selectively communicate a projection light beam along a projection light path; and

- at least one adjustable aperture positioned in the projection light path and operable to selectively vary an amount of the projection light beam communicated from the modulator, the adjustable aperture comprising a notch that operates to reduce the effect of the adjustable aperture on a high intensity light associated with the projection light beam and wherein the notch communicates at least a majority of the high intensity light associated with the projection light beam, as discloses in claim 12.

+++ An adjustable aperture system, comprising:

- an adjustable aperture comprising a notch and capable of varying an amount of projection light communicated through the light bundle, wherein the notch operates to reduce the effect of the adjustable aperture on a high intensity light communicated through the light bundle and wherein the notch communicates at least a majority of the high intensity light communicated through the light bundle; and
- a control motor operable to receive a control signal, as discloses in claims 19.

The underlined limitations are critically, since the adjustable aperture system can remove a portion of a lower intensity light communicated through a

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light bundle, and reduce the effect of the adjustable aperture on high intensity light communicated through the light bundle.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

CONTACT INFORMATION

3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to PHAN T.H. PALMER whose telephone number is (571) 272-2354. The examiner can normally be reached on Monday to Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, RODNEY B. BOVERNICK can be reached on (571) 272-2344. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

PTHP 10/31/2005